

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/526,906	NAKAYAMA ET AL.
	Examiner	Art Unit
	Caixia Lu	1713

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
502	103,115	3-2-07	CR
526	1242,1243	1	1